

Inventor Information

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Application Information

Title Line One::	SCANNING EXPOSURE METHOD AND SYSTEM
Total Drawing Sheets::	28

Docket Number:: 108483

Prior Foreign Applications

Foreign Application One:: JP 2000-025661
Filing Date:: February 2, 2000
Country:: Japan
Priority Claimed:: yes
Foreign Application Two:: JP 2000-026630
Filing Date:: February 3, 2000
Country:: Japan
Priority Claimed:: yes

FILED TO CORRECT